

Notice of References Cited	Application/Control No. 10/573,396		Applicant(s)/Patent Under Reexamination KIM ET AL.	
	Examiner BENJAMIN ELLIOTT		Art Unit 4144	Page 1 of 1

U.S. PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
*	A	US-5,778,187	07-1998	Monteiro et al.	709/231
*	B	US-2004/0193609	09-2004	Phan et al.	707/010
*	C	US-7,296,091	11-2007	Dutta et al.	709/245
*	D	US-4,792,947	12-1988	Takiyasu et al.	370/452
*	E	US-2004/0221007	11-2004	Roe et al.	709/203
*	F	US-7,069,312	06-2006	Kostic et al.	709/220
*	G	US-2005/0002639	01-2005	Putterman et al.	386/046
*	H	US-2004/0243700	12-2004	Weast, John C.	709/224
*	I	US-7,007,086	02-2006	Zhu et al.	709/224
*	J	US-7,031,945	04-2006	Donner, Irah H.	705/64
	K	US-			
	L	US-			
	M	US-			

FOREIGN PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Country	Name	Classification
	N					
	O					
	P					
	Q					
	R					
	S					
	T					

NON-PATENT DOCUMENTS

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
	U	
	V	
	W	
	X	

*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)
Dates in MM-YYYY format are publication dates. Classifications may be US or foreign.